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1/10 FIG.1

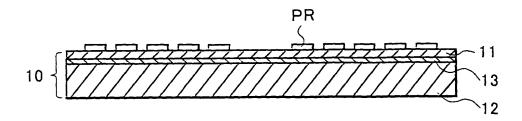


FIG.2

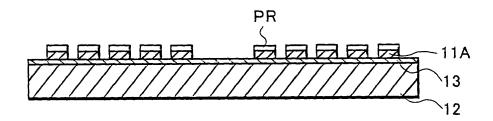


FIG.3

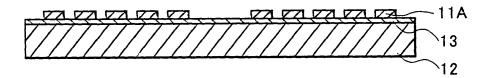
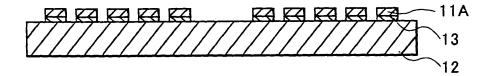


FIG.4



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FIG.5

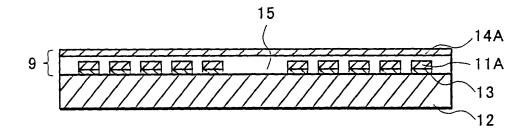


FIG.6

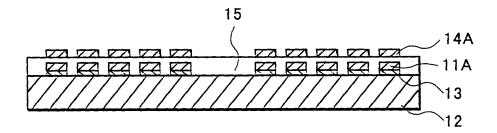
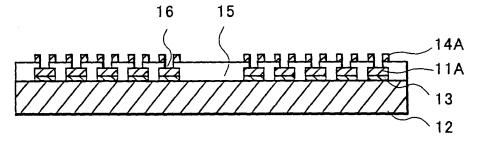


FIG.7



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FIG.8

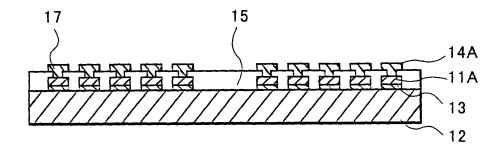


FIG.9

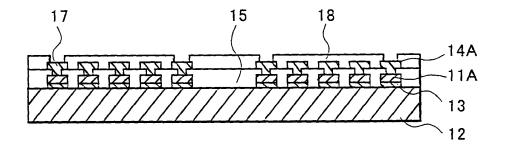
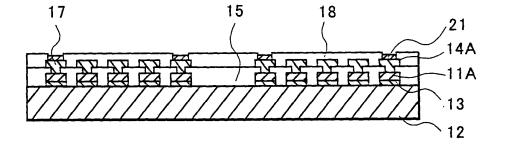


FIG.10



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FIG.11

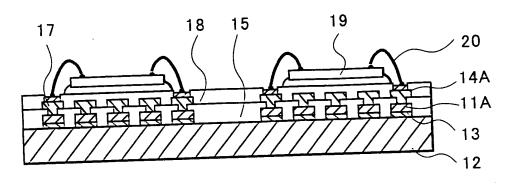


FIG.12

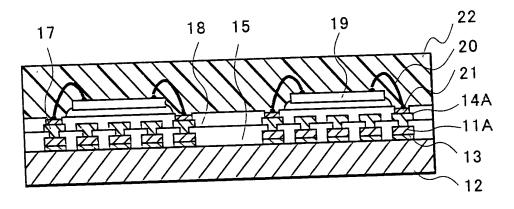
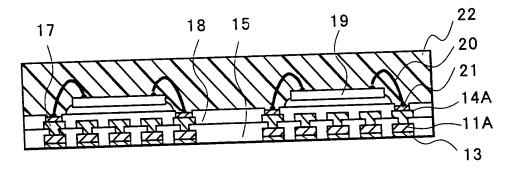


FIG.13



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FIG.14

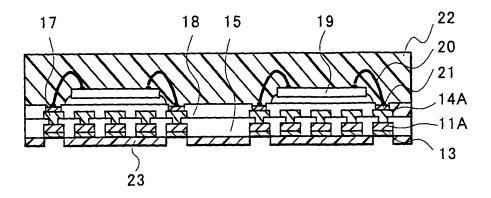


FIG.15

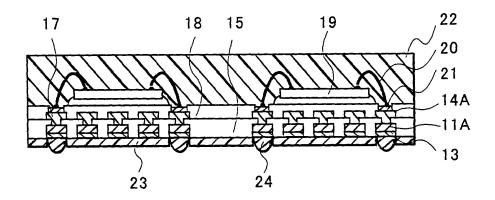


FIG.16

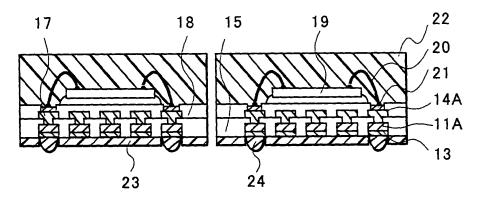
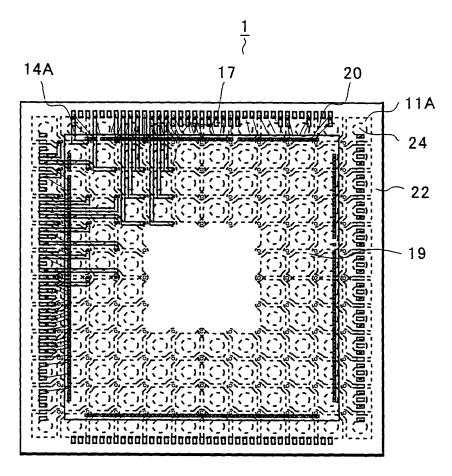


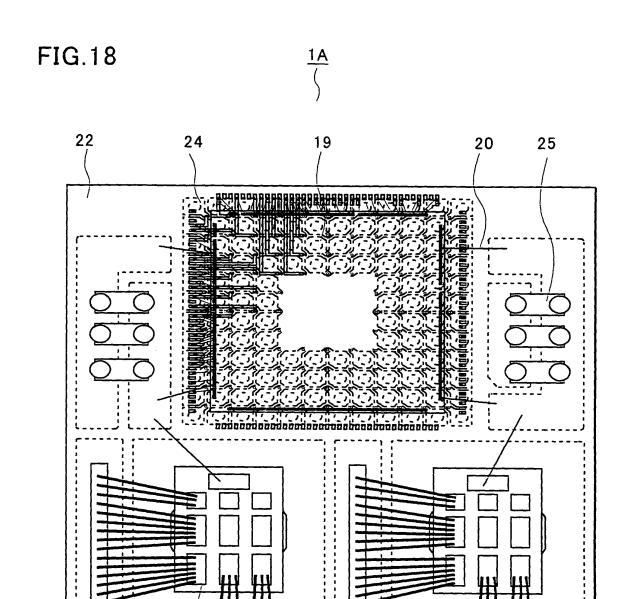
FIG.17



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11A

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FIG.19

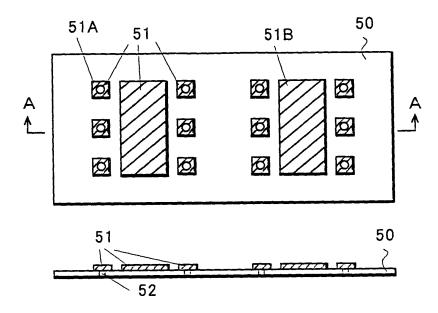


FIG.20

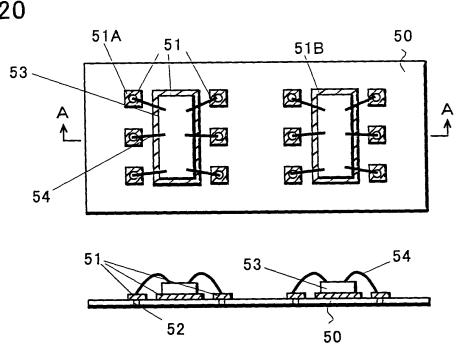


FIG.21A

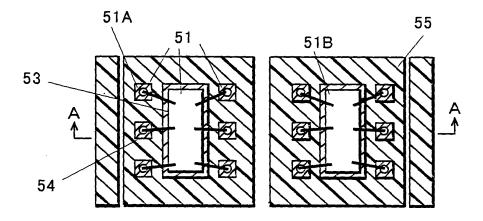


FIG.21B

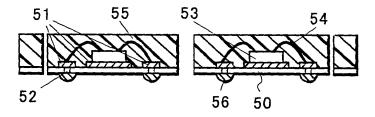
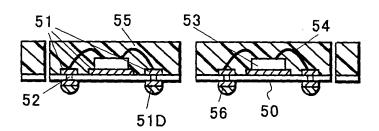


FIG.21C



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FIG.22

